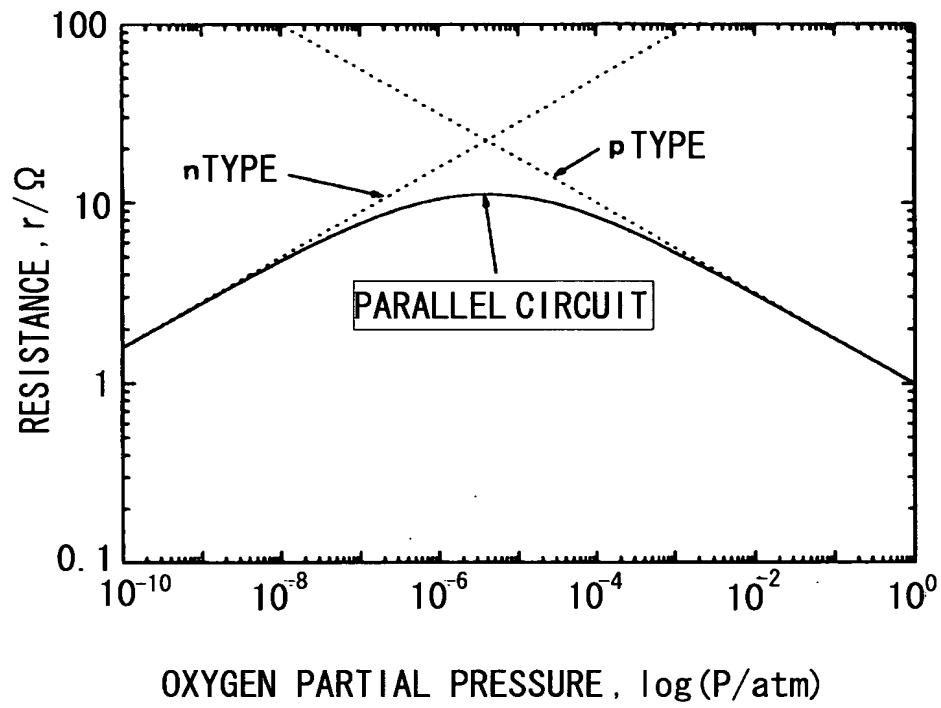
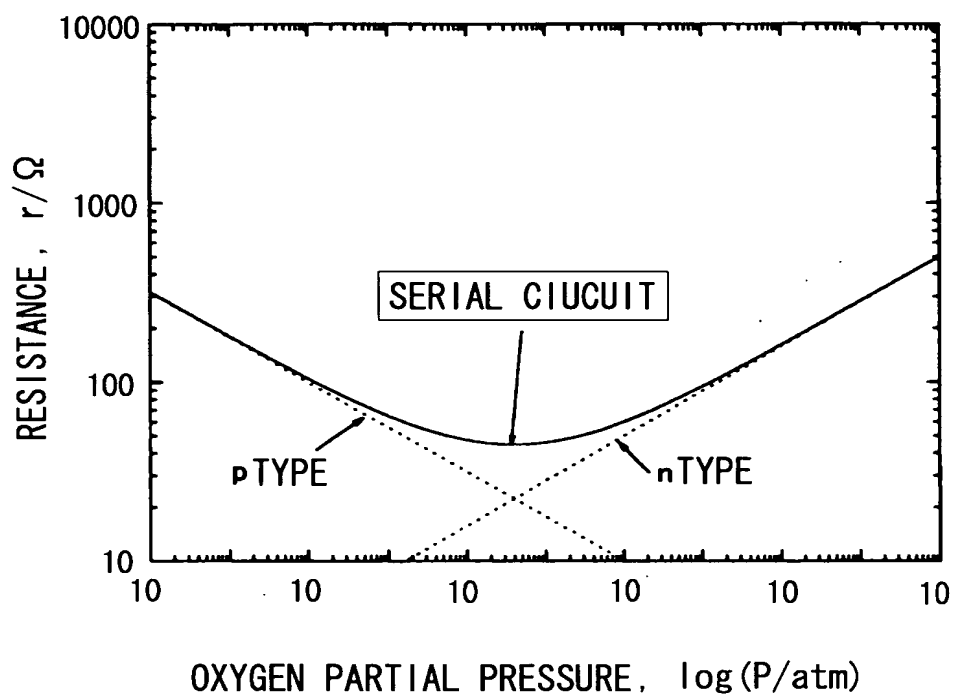


1 / 1 2



F i g . 1

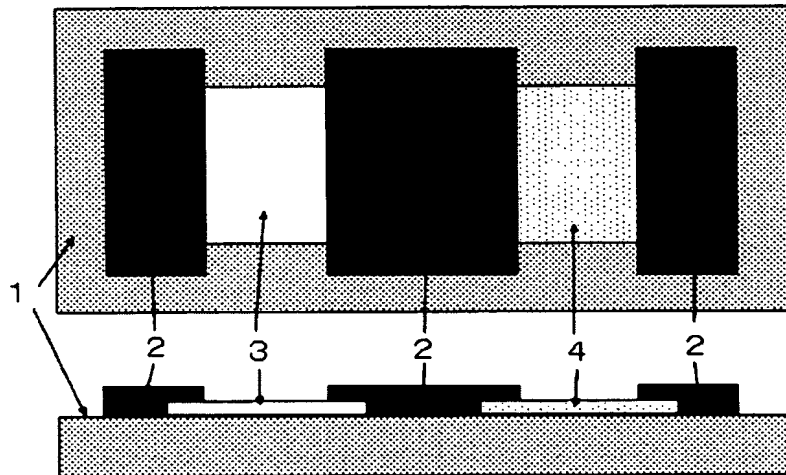
2 / 12



F i g . 2

BEST AVAILABLE COPY

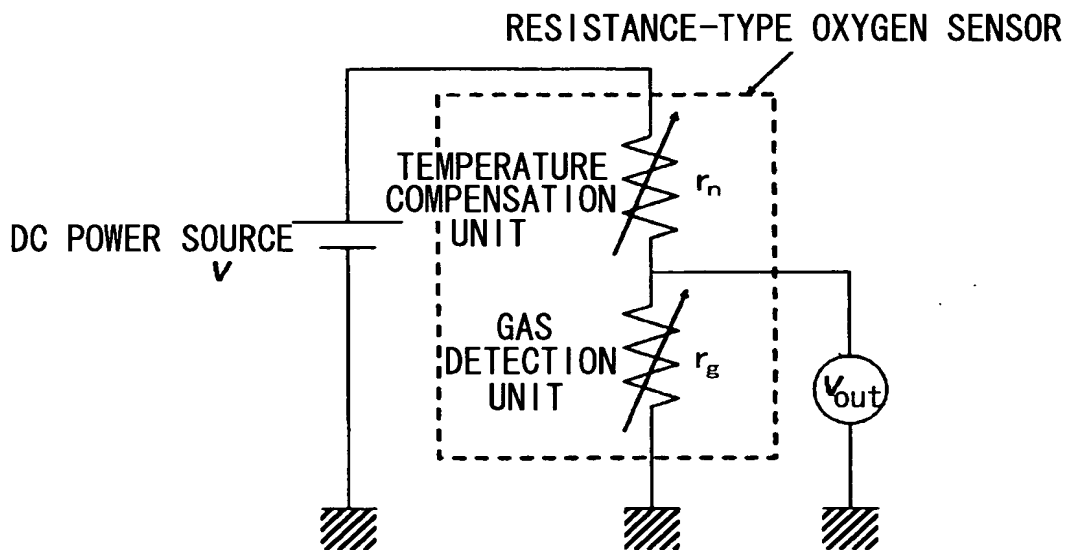
3 / 1 2



- 1 ... SUBSTRATE
- 2 ... ELECTRODE
- 3 ... GAS DETECTION UNIT (OXIDE SEMICONDUCTOR)
- 4 ... TEMPERATURE COMPENSATION UNIT
(OXYGEN ION CONDUCTOR)

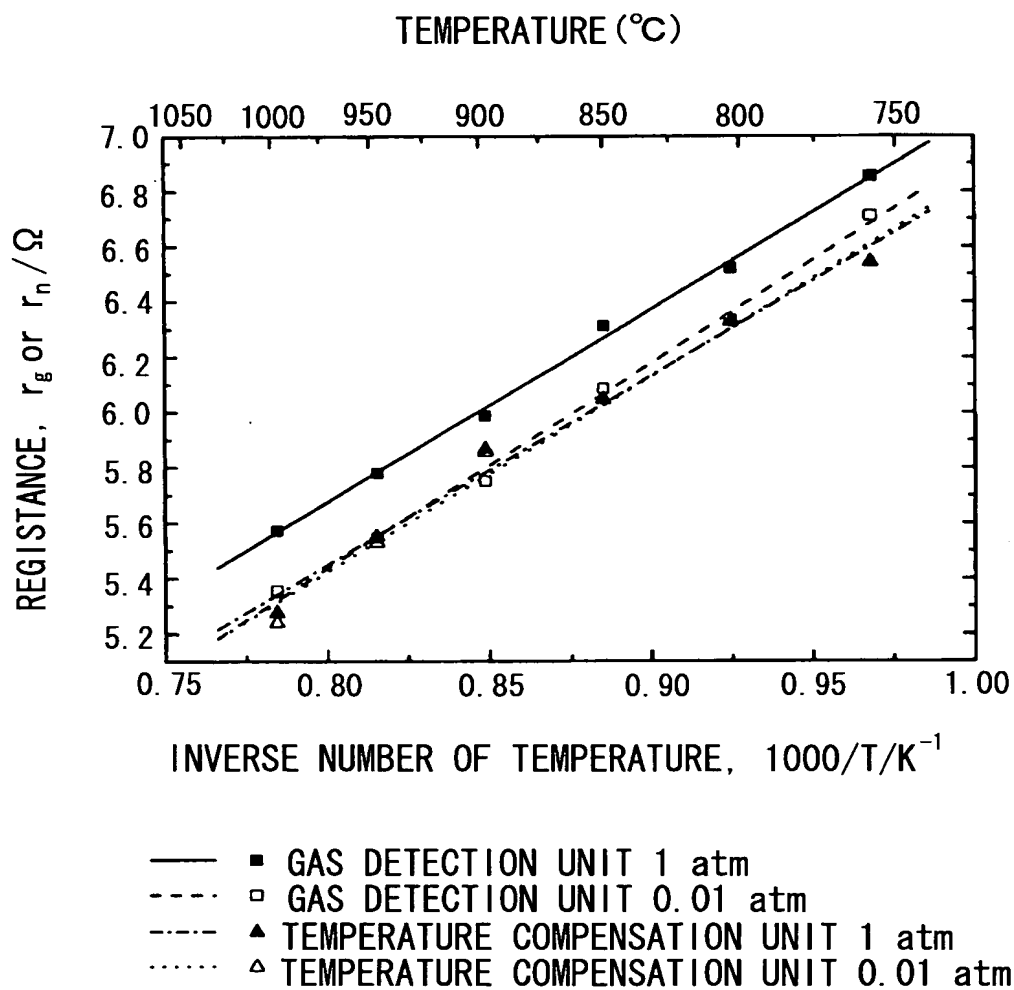
F i g . 3

4 / 1 2



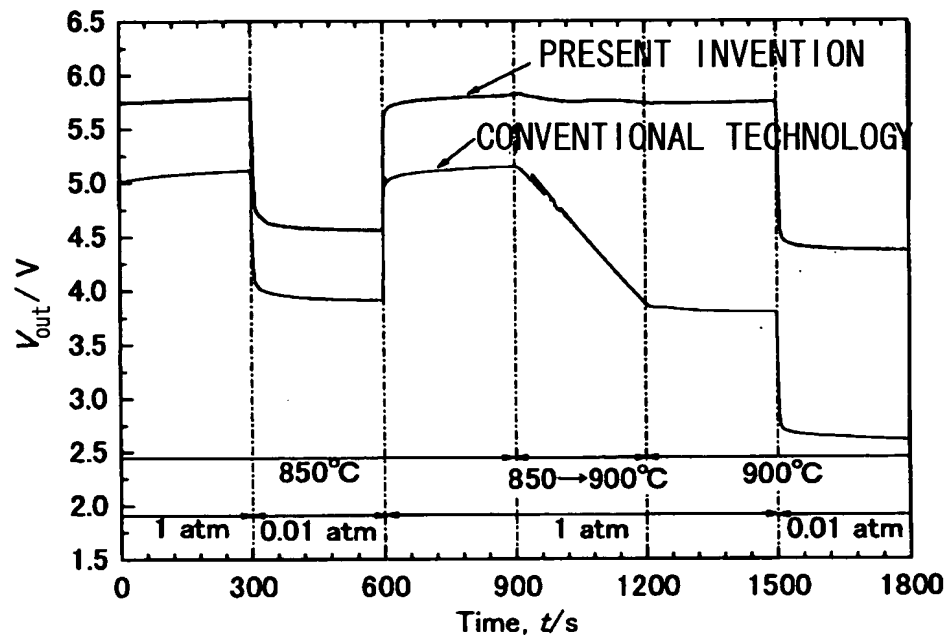
F i g . 4

5 / 1 2



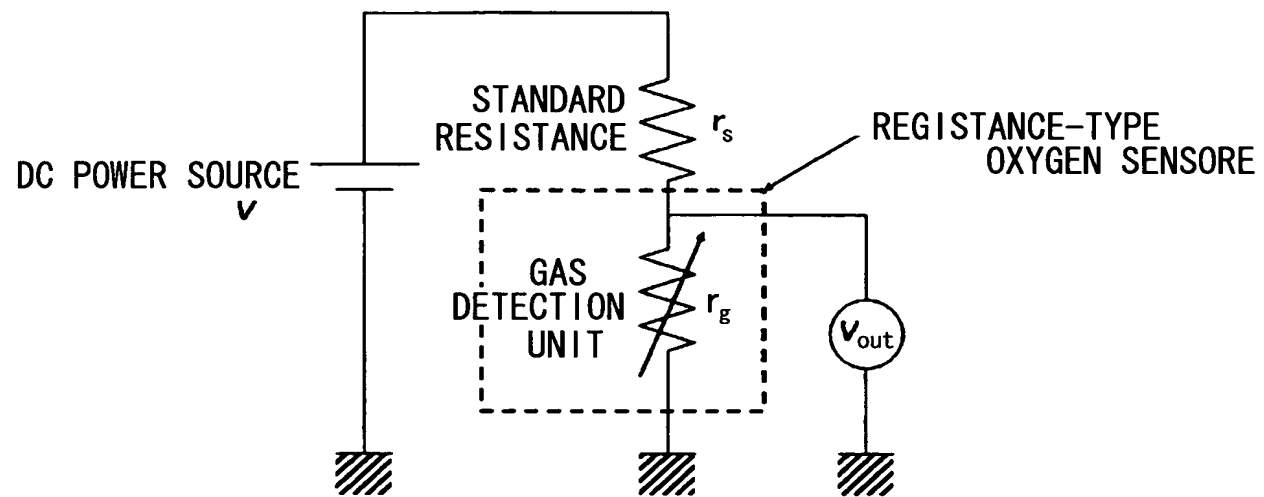
F i g . 5

6 / 1 2



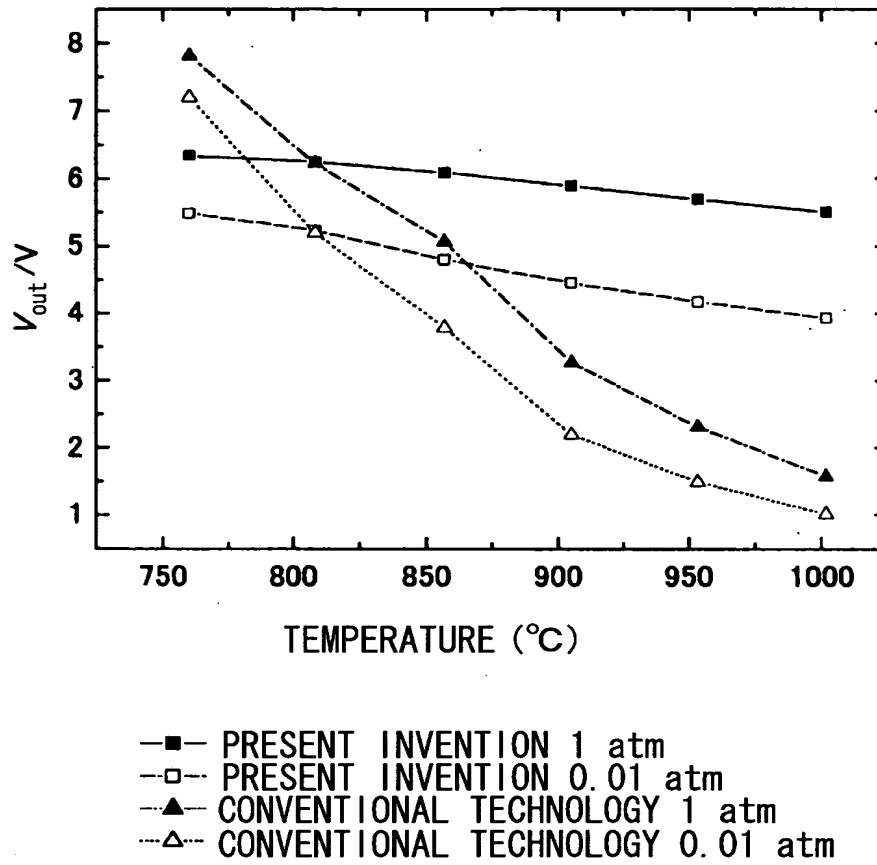
F i g . 6

7 / 1 2



F i g . 7

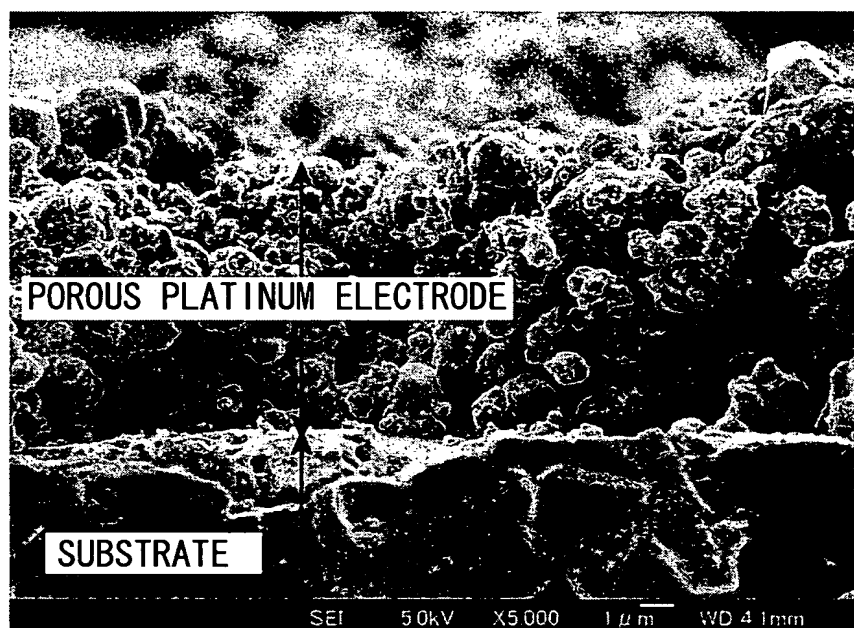
8 / 1 2



F i g . 8

BEST AVAILABLE COPY

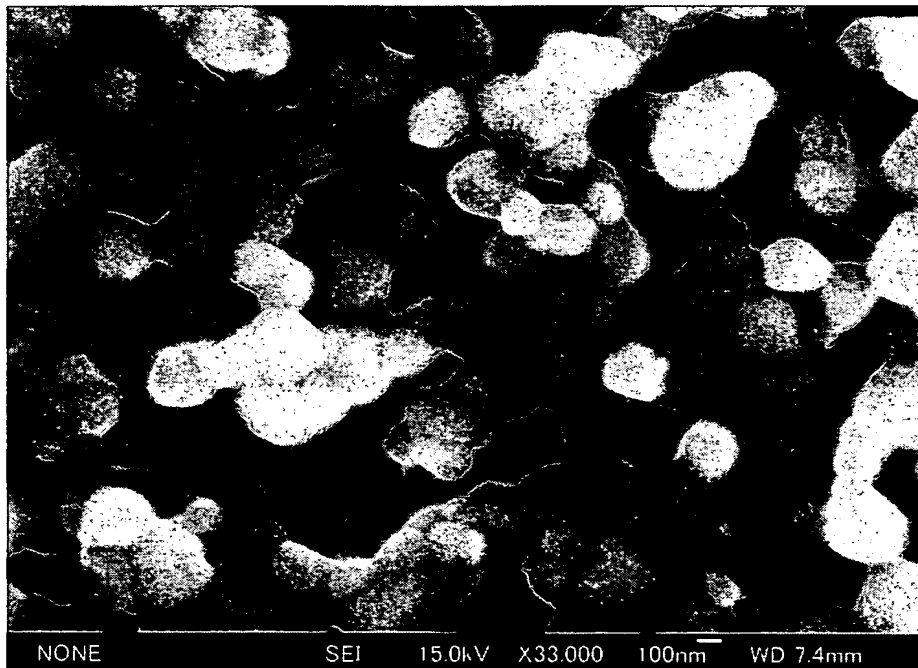
9 / 1 2



F i g . 9

BEST AVAILABLE COPY

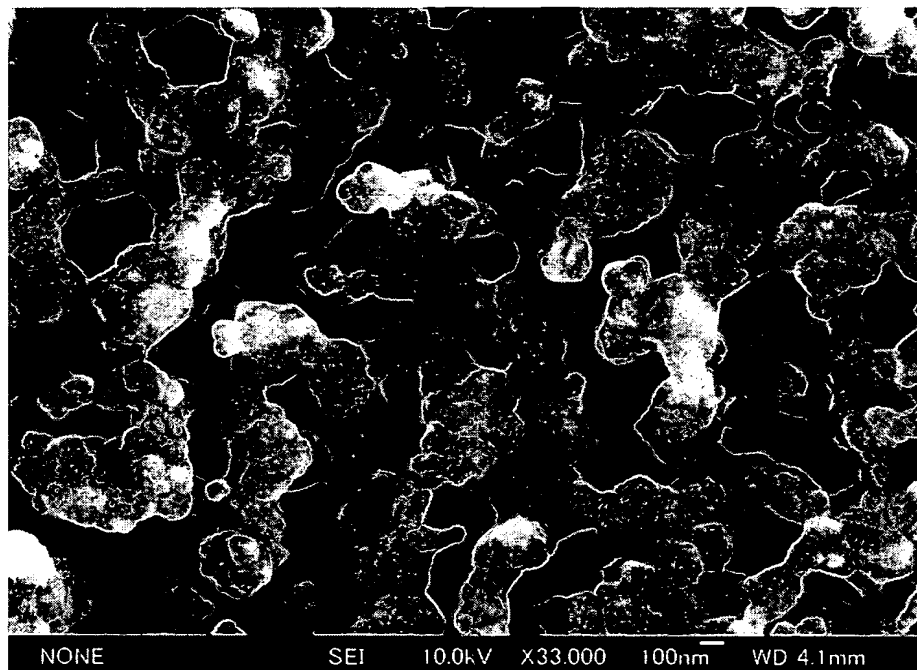
10 / 12



F i g . 1 0

BEST AVAILABLE COPY

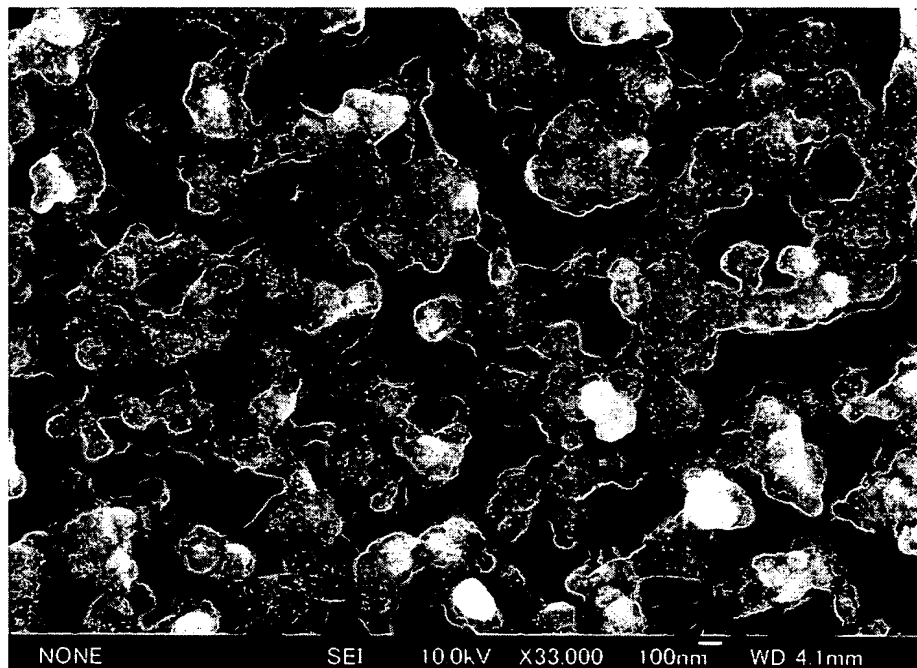
11 / 12



F i g . 1 1

BEST AVAILABLE COPY

12 / 12



F i g . 12